

Photocathodes Characterization Techniques - Basics

Elena Echeverria
Postdoctoral Associate - Theme 1

CBB Annual Meeting - July 22/2023





- 1 Intro
- 2 Quantum Efficiency (QE)
- 3 RHEED (Reflection high energy electron diffraction)
- 4 XPS (X-ray photoemission spectroscopy)
- 5 MTE (Mean Transverse Energy)
- 6 Summary



Overview

- 1 Intro
- 2 Quantum Efficiency (QE)
- 3 RHEED (Reflection high energy electron diffraction)
- 4 XPS (X-ray photoemission spectroscopy)
- 5 MTE (Mean Transverse Energy)
- 6 Summary



Photocathodes for Bright Beams

Normalized brightness is defined by:

$$B_n = \frac{2m_e c^2 I}{\sigma_x^2 MTE}$$

I → Beam Current: Quantum Efficiency, laser fluency, lifetime

MTE → Mean Transverse Energy: Intrinsic Momentum spread + roughness + laser heating + ...



Photocathodes for Bright Beams

Normalized brightness is defined by:

$$B_n = \frac{2m_e c^2 I}{\sigma_x^2 MTE}$$

I → Beam Current: Quantum Efficiency, laser fluency, lifetime

MTE → Mean Transverse Energy: Intrinsic Momentum spread + roughness + laser heating + ...

Goal:

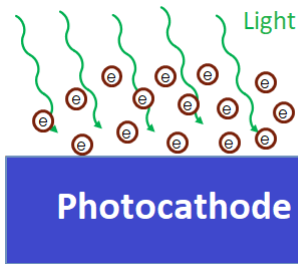
Photocathodes with high QE and low MTE



Photocathodes for Bright Beams

Goal: Photocathodes with high QE and low MTE

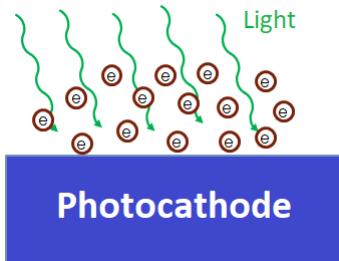
$$EQE = \frac{\text{Average } e^-}{\text{Incident photons}}$$



Photocathodes for Bright Beams

Goal: Photocathodes with high **QE** and low MTE

$$EQE = \frac{\text{Average } e^-}{\text{Incident photons}}$$

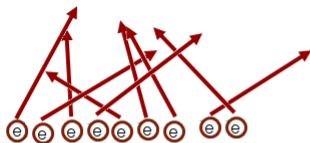


Candidates: (Bi)Alkali antimonides thin films (Cs_3Sb , K_2CsSb , Na_2KSb ...)



Photocathodes for Bright Beams

Goal: Photocathodes with high QE and low **MTE (Mean Transverse Energy)**



Photocathode

High MTE



Photocathode

Low MTE



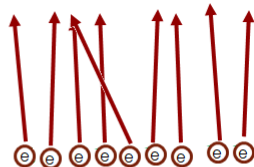
Photocathodes for Bright Beams

Goal: Photocathodes with high QE and low **MTE (Mean Transverse Energy)**



Photocathode

High MTE



Photocathode

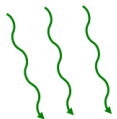
Low MTE

One solution: **Flat and ordered films**



Deposition System → Molecular Beam Epitaxy (MBE)

Thin films can be obtained in our system

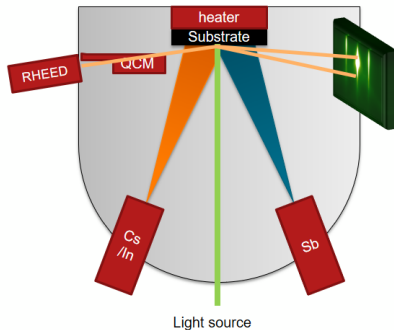


Photocathode film:
<10 nm thickness

3C-SiC(100) ~ 1.3 μm

Si ~ 0.5 mm

Our growth method:
RHEED monitored
Structure oriented



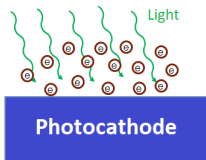
Overview

- 1 Intro
- 2 Quantum Efficiency (QE)**
- 3 RHEED (Reflection high energy electron diffraction)
- 4 XPS (X-ray photoemission spectroscopy)
- 5 MTE (Mean Transverse Energy)
- 6 Summary

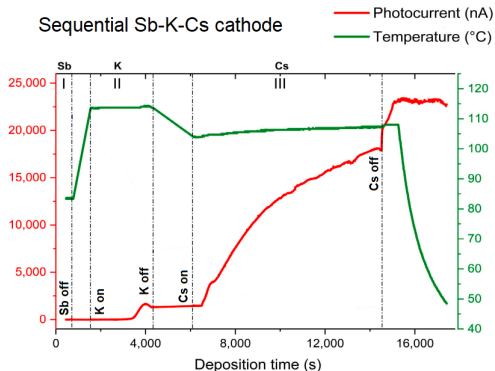


Quantum Efficiency (QE)

in situ most used technique to define the cathode growth



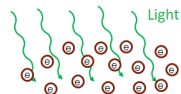
$$EQE = \frac{\text{Average } e^{-}}{\text{Incident photons}}$$



Modif. from **Micromachines** 2023, 14, 1182



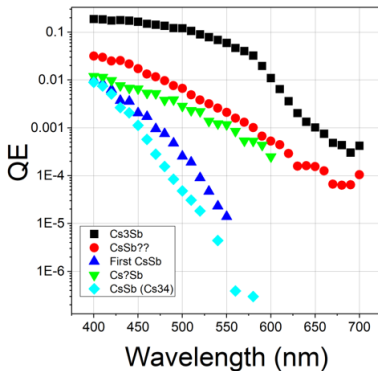
Spectral Response



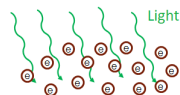
Photocathode

$$EQE = \frac{\text{Average } e^-}{\text{Incident photons}}$$

Spectral Response



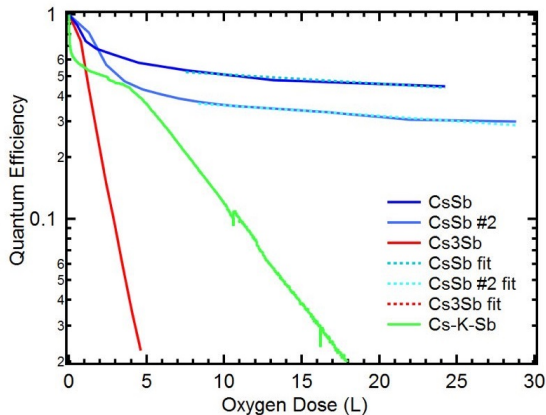
Oxidation Experiments



Photocathode

$$EQE = \frac{\text{Average } e^-}{\text{Incident photons}}$$

Oxidation Experiments



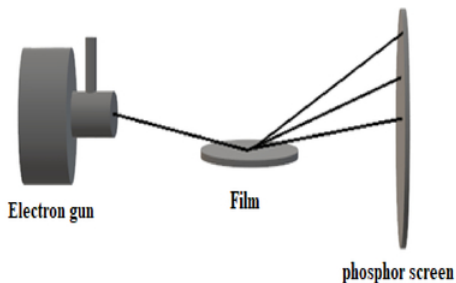
Overview

- 1 Intro
- 2 Quantum Efficiency (QE)
- 3 RHEED (Reflection high energy electron diffraction)**
- 4 XPS (X-ray photoemission spectroscopy)
- 5 MTE (Mean Transverse Energy)
- 6 Summary



Reflection high energy electron diffraction

RHEED → Crystal Structure

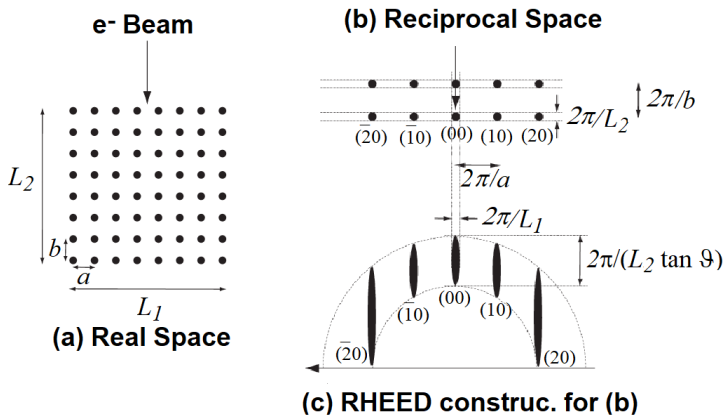


Source	Electron Gun
Energy	$1 \text{ keV} < E < 30 \text{ keV}$
Depth	surface
Angle	$< 5^\circ$

<https://doi.org/10.1117/12.2585204>



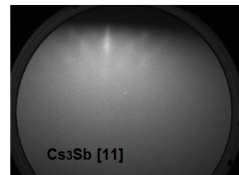
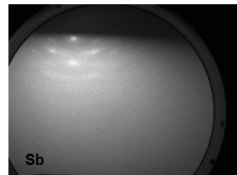
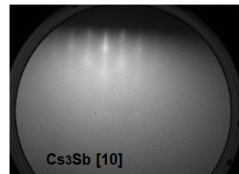
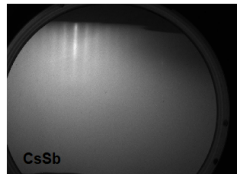
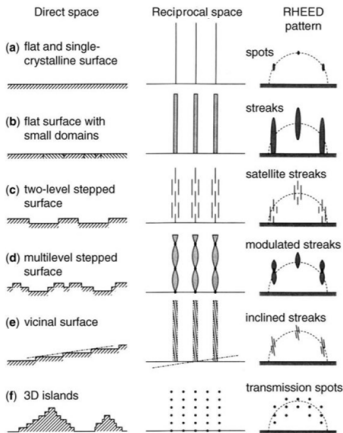
RHEED → Diffraction Patterns



Ichimiya & Cohen (2004) Reflection High-Energy Electron Diffraction
 doi:10.1017/CBO9780511735097



RHEED → More Diffraction Patterns



<https://phas.ubc.ca/~berciu/TEACHING/PHYS502/PROJECTS/RHEED.pdf>

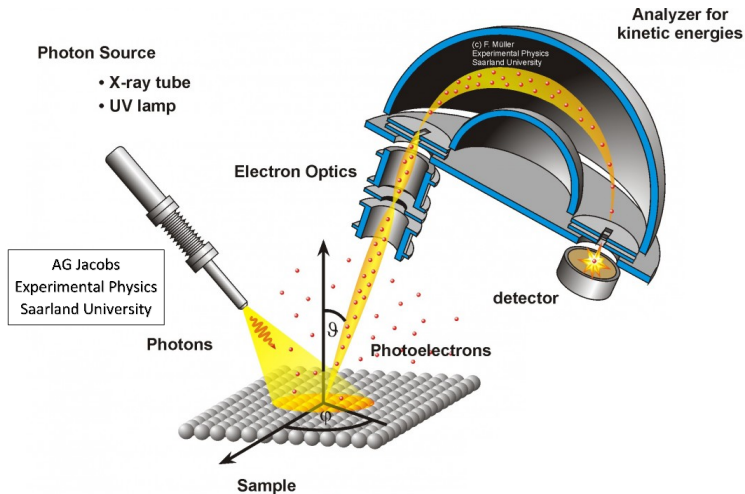


Overview

- 1 Intro
- 2 Quantum Efficiency (QE)
- 3 RHEED (Reflection high energy electron diffraction)
- 4 XPS (X-ray photoemission spectroscopy)**
- 5 MTE (Mean Transverse Energy)
- 6 Summary

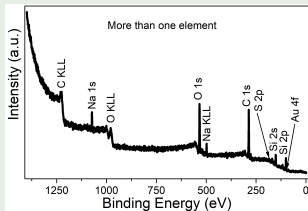
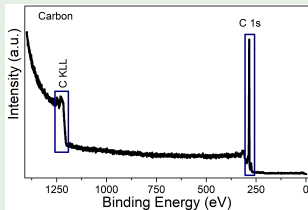


XPS → Elemental composition/chemical state of elements

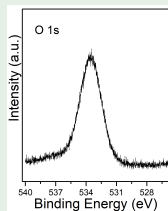
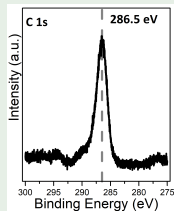
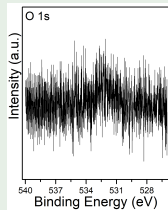
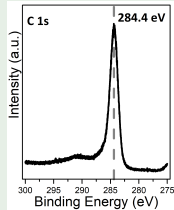


Two types of spectra are collected

Surveys or Wide Scans

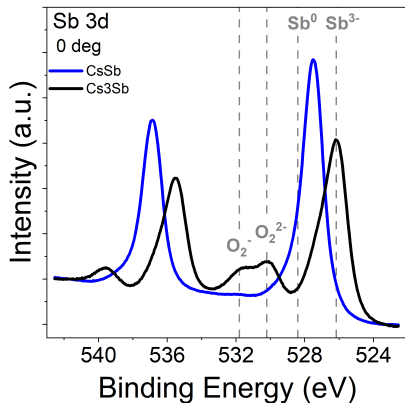


Zooms

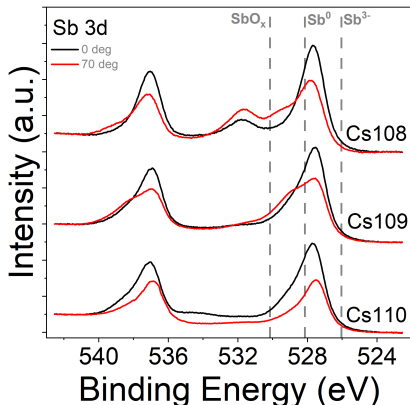


In the case of Cesium Antimonide

CsSb vs Cs₃Sb



“Bulk” vs Surface (Cs_xSb_y)



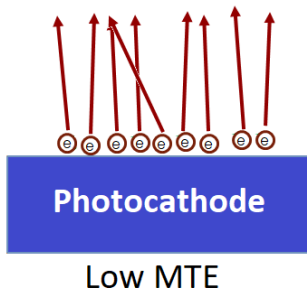
Overview

- 1 Intro
- 2 Quantum Efficiency (QE)
- 3 RHEED (Reflection high energy electron diffraction)
- 4 XPS (X-ray photoemission spectroscopy)
- 5 MTE (Mean Transverse Energy)**
- 6 Summary

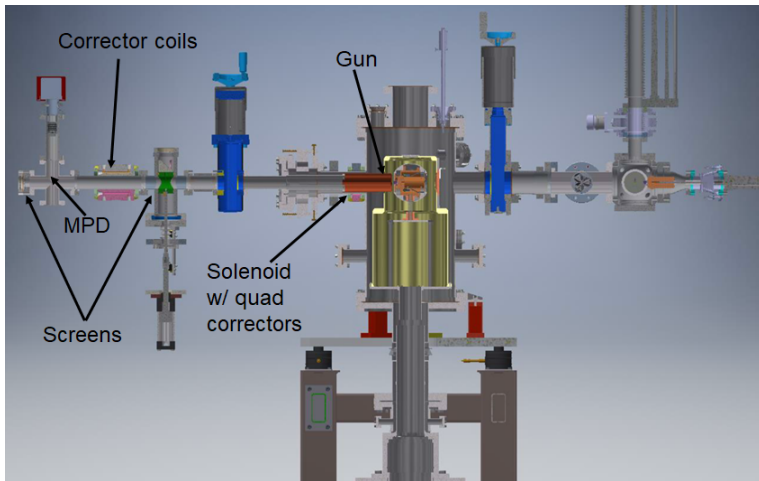


MTE (Mean Transverse Energy)

- Quantifies the angular spread of the electron beam coming off from the cathode
- Along with the spot size of the photoemitting laser, limits the beam brightness

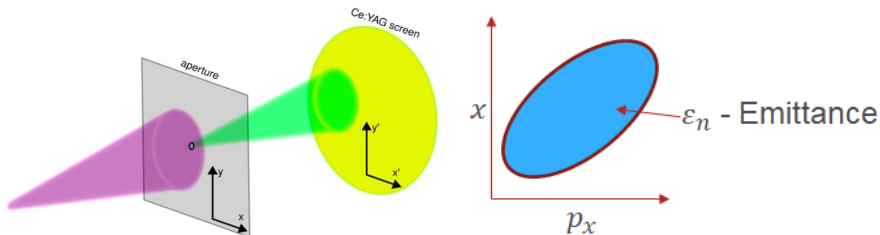


Beamline → MTE meter setup at Cornell



x-y components of the momentum

An aperture scan is used to record the beam image on a screen to subsequently recover the transverse phase space of the emitted beam



From here, the emittance is measured and therefore the MTE is calculated

$$\epsilon_n = \sigma_x \sqrt{\frac{MTE}{m_e c^2}}$$



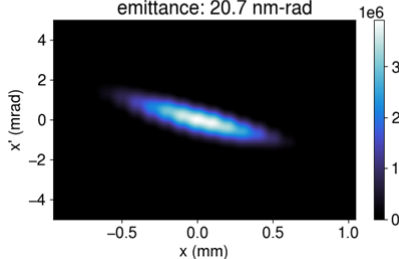
Phase Space Images

350 meV MTE

σ_x : 265.0 μm

$\sigma_{x'}$: 0.6 mrad

emittance: 20.7 nm-rad

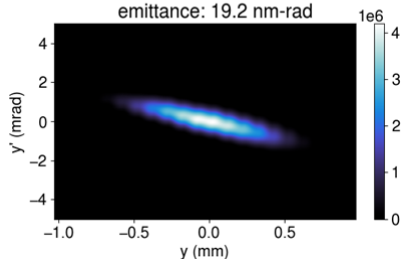


301 meV MTE

σ_y : 279.0 μm

$\sigma_{y'}$: 0.6 mrad

emittance: 19.2 nm-rad



Taken from William Li, Theme 1 meeting, April 4th 2022

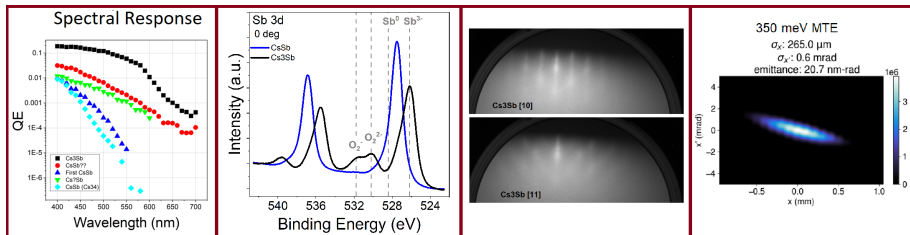


Overview

- 1 Intro
- 2 Quantum Efficiency (QE)
- 3 RHEED (Reflection high energy electron diffraction)
- 4 XPS (X-ray photoemission spectroscopy)
- 5 MTE (Mean Transverse Energy)
- 6 Summary**



Summary



Thanks! Questions?

